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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Wayne G. Renken  
Title: Process Condition Sensing Wafer and Data Analysis System  
Application No.: 10/056,906 Filing Date: January 24, 2002  
Examiner: Charles D. Garber Group Art Unit: 2856  
Docket No.: SENS.005US0 Conf. No.: 2359

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PETITION FOR EXTENSION OF TIME**

Dear Sir:

Applicant(s) respectfully petition(s) for a one-month extension of time within which to respond to the outstanding Response to Office Action of Nonprovisional Application, such extension allowing the undersigned until May 12, 2004 to respond.

A check is enclosed that includes the amount of \$55.00, as set forth in the enclosed transmittal letter.

Date: May 12, 2004

Respectfully submitted,

Peter A. Gallagher  
Reg. No.47,584

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